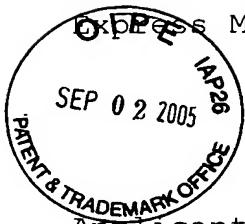


PATENT APPLICATION



Express Mail Label No.: None

IN THE U.S. PATENT AND TRADEMARK OFFICE

August 31, 2005

Applicants : Takaomi NAKAYAMA et al

For : TREATING SOLUTION FOR SURFACE TREATMENT OF
METAL AND A METHOD FOR SURFACE TREATMENT

PCT International Application No.: PCT/JP2003/015868

PCT International Filing Date: December 11, 2003

U.S. Application No.

(if known, see 37 CFR 1.5): 10/537 329

Atty. Docket No.: 4626.P0002US

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

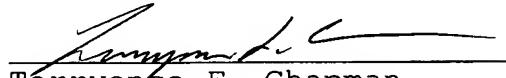
In compliance with the provisions of Rules 1.97(b)(1) and 1.98, enclosed herewith is Form PTO-1449 and the references cited thereon. These references are mentioned in Applicants' specification. Further comment at this point in time should not be necessary.

JP 8-176841 corresponds to WO 96/19595. JP 9-25436 corresponds to EP 0 838 537. JP 9-31404 corresponds to U.S. 6 059 896. JP 2000-199077 corresponds to U.S. 6 361 833. JP 5-195244 corresponds to U.S. 5 449 414. WO 02/103080 corresponds to U.S. 2004/0244874.

Since this application was filed after June 30, 2003, Applicants hereby accept the USPTO waiver of the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent [1273 Off. Gaz. Pat. Off. 55, 8/05/2003].

Further consideration is respectfully solicited.

Respectfully submitted,



Terryence F. Chapman

TFC/smd

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Encl: Form PTO-1449 and one copy of each non-U.S. reference
listed thereon
Postal Card

336.05/03

INFORMATION DISCLOSURE CITATION	Applicant: Takaomi NAKAYAMA et al Serial: 10/537 329 Filed: June 1, 2005 Conf. No.: Unknown Atty. Docket No.: 4626.P0002US Group: Unknown
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SEP 02 2005

U.S. PATENT DOCUMENTS				
Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
		4 273 592	06-16-1981	KELLY
	AB	4 313 769	02-02-1982	FRELIN et al
	AC	5 380 374	01-10-1995	TOMLINSON
	AD	5 449 414	09-12-1995	DOLAN
	AE	6 059 896	05-09-2000	EHARA et al
	AF	6 361 833 B1	03-26-2002	NAKADA et al
	AG	2004/0244874 A1	12-9-2004	NAKAYAMA et al

FOREIGN PATENT DOCUMENTS

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	AI	JP 2000-204485	07-25-2000	SHIMAKURA	X
	AJ	JP 56-136978	10-26-1981	FUJIMOTO et al	Abstract
	AK	JP 8-176841	07-09-1996		
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	AM	JP 9-25436	01-28-1997		
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	AP	JP 2000-199077	07-18-2000		
	AQ	JP 5 195 244	08-03-1993		
	AR	WO 02/103080 A1	12-27-2002		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AS	
	AT	
EXAMINER SIGNATURE		DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.